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BC  
Paper No.

In re application of  
Mark C. Huth et al.  
Serial No. 10/076,467  
Filed: February 15, 2002  
For: LASER MICROMACHINING AND METHODS AND SYSTEMS  
OF SAME

: DECISION ON  
: PETITION  
: :

This communication is in response to the PETITION TO WITHDRAW HOLDING OF ABANDONMENT, filed August 25, 2004, for failure to respond to the Office Action dated December 1, 2003. On November 23, 2004, the applicants filed a request to withdraw the Petition filed on August 25, 2004 in favor of a newly submitted PETITION FOR REVIVAL OF AN APPLICATION FOR PATENT ABANDONED UNAVOIDABLY UNDER 37 CFR 1.137(a).

Accordingly, this Petition is herein **DISMISSED**.

Upon the mailing of this communication, the newly submitted PETITION UNDER 37 CFR 1.137(a) will be forwarded to the Office of Petitions for consideration.

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